

Notice of References Cited	Application/Control No. 10/709,722	Applicant(s)/Patent Under Reexamination STAMPER, ANTHONY K.	
	Examiner Chris C. Chu	Art Unit 2815	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-2002/0055243	05-2002	Lee, Chiu-Te	438/586
	B	US-6,245,662	06-2001	Naik et al.	438/622
	C	US-6,333,265	12-2001	Dixit et al.	438/680
	D	US-6,177,329	01-2001	Pang, Kurt	438/400
	E	US-6,531,755	03-2003	Usami, Tatsuya	257/520
	F	US-6,265,321	07-2001	Chooi et al.	438/725
	G	US-2002/0175417	11-2002	Morrow, Patrick	257/758
	H	US-2002/0158337	10-2002	Babich et al.	257/758
	I	US-6,297,554	10-2001	Lin, Min-Yi	257/752
	J	US-6,103,619	08-2000	Lai, Yeong-Chih	438/638
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
	V	
	W	
	X	

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.